

**INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT**

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ATTY. DOCKET NO.  
**050024-0015**SERIAL NO.  
**10/635,777**APPLICANT  
**Akiyoshi MIKAMI**FILING DATE  
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**1794****U.S. PATENT DOCUMENTS**

EXAMINER'S INITIALS	CITE NO.	Document Number Number-Kind Code(s if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
	US				

**FOREIGN PATENT DOCUMENTS**

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**OTHER ART (including Author, Title, Date, Pertinent Pages, Etc.)**

EXAMINER'S INITIALS	CITE NO.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	
/CT/		MIKAMI et al "Chemical Vapor Deposition of ZnS: Mn Electroluminescent Films in a Low-Pressure Halogen Transport System" Journal of Chrystal Growth 110 (1991) pages 381-394 Elsevier Science Publishers B.V. North Holland	

EXAMINER  
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1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.